

13/B 2813
10/14/03
Mullish



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Chakravarthi et al.

Docket No.: TI-33161

Serial No.: 10/020,813

Art Unit: 2813

Filed: 12/12/01

Examiner: Huynh, Yennhu

Title: Fabrication of Ultra Shallow Junctions From a Solid Source With Fluorine Implantation

AMENDMENT UNDER 37 CFR 1.111

October 2, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)			
I hereby certify that the above correspondence is being deposited			
with	the	U.S.	Postal Service on
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envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450			
Karen Vertz		10-2-03	
Karen Vertz		Date	

In response to the Office Action, dated 08/01/2003, in the above-identified patent application, please make the following amendments. They are respectfully submitted as a full and complete response to that Action. Charge any required fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.